



Attorney Docket : 33773M013

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Takahiro Saito

Serial No.: 09/752,563

Group Art Unit: 3724

Filed : January 3, 2001

Examiner: C. Goodman

For : METHOD OF CUTTING CSP SUBSTRATES

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicant is enclosing an Information Disclosure Citation Form (PTO-1449) and a copy of the documents cited therein.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

An Official Action on the merits has issued for this application. In accordance with the requirements of 37 C.F.R. §1.97(d), Applicant attaches a check for \$180 in payment of the requisite fee (37 C.F.R. §1.17(p)).


Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP



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PATENT TRADEMARK OFFICE

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